

Study of charge collection properties of silicon microstrip detectors with different read out geometries after high doses of proton irradiation



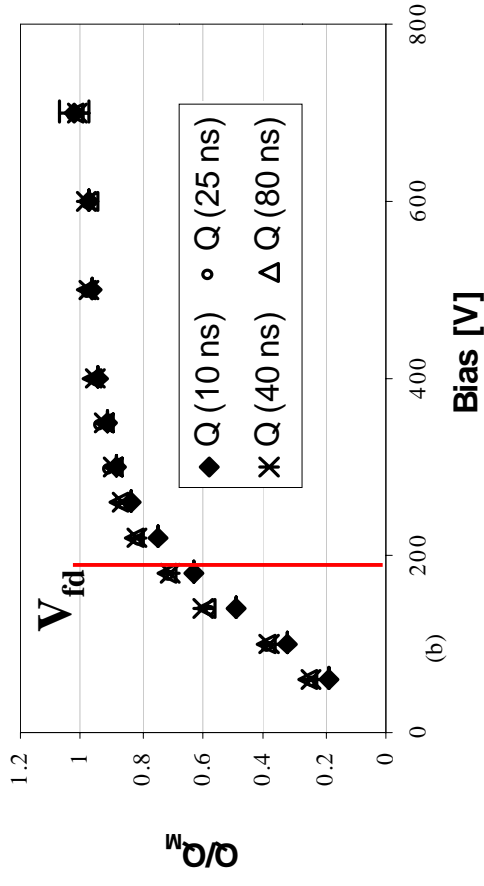
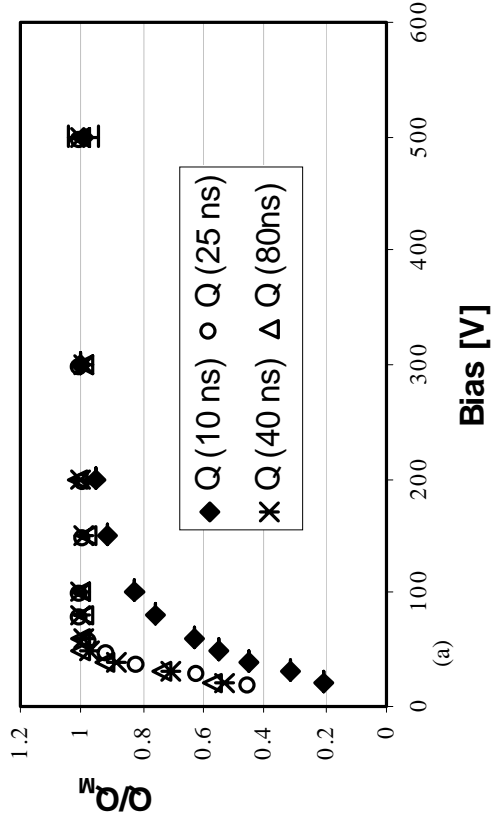
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Outline:

- Introduction
- ISE simulation of non-irradiated and irradiated devices
- Non-homogeneous irradiation of large area microstrip detectors
- Study of the non-homogeneously irradiated detector - CCE(V) and charge sharing -
- Signal/noise as a function of the irradiation
- Conclusions

CCE in silicon diodes before and after irradiation ($4 \times 10^{14} \text{ cm}^{-2}$)



The radiation damage introduces charge trapping and changes in V_{FD} , electric field profile, dielectric properties of non-depleted bulk

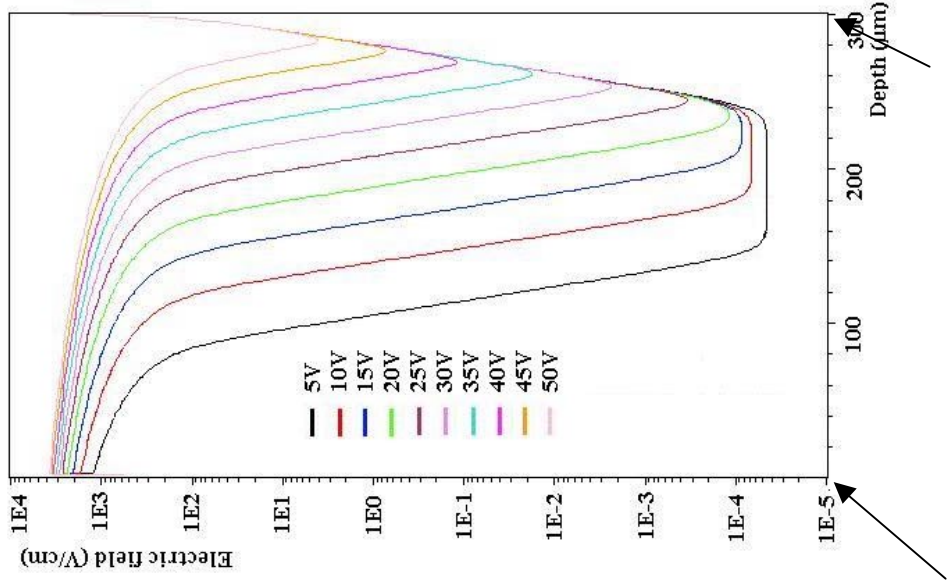
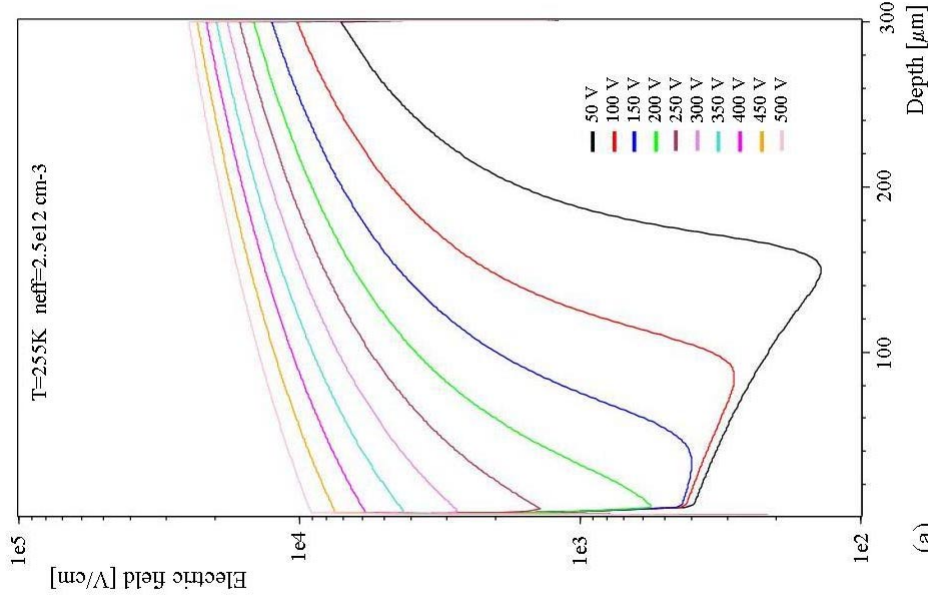


We use ISE-TCAD to simulate non-irradiated and irradiated silicon detectors.

The radiation effects have been introduced by electron and hole traps in the silicon band-gap. The trap density below corresponds to a fluence of 1×10^{15} 1MeV neutron equivalent cm^{-2} .

Trap type	Trap density [cm^{-3}]	Energy from mid band gap [V]	El. capture cross section [cm^{-2}]	Hole capture cross section [cm^{-2}]
*Electron	1.50×10^{15}	0.39	1.00×10^{-14}	5.50×10^{-13}
*Electron	2.20×10^{15}	0.13	2.00×10^{-15}	1.20×10^{-14}
Electron	3.60×10^{14}	0.035	1.20×10^{-15}	1.20×10^{-14}
Hole	3.24×10^{14}	-0.045	1.20×10^{-14}	1.20×10^{-15}
*Hole	1.50×10^{15}	-0.20	1.50×10^{-14}	2.00×10^{-15}

ISE simulation of the electric field profile in a n-bulk silicon diode before and after irradiation ($4 \times 10^{14} \text{ p cm}^{-2}$)



p⁺-implant

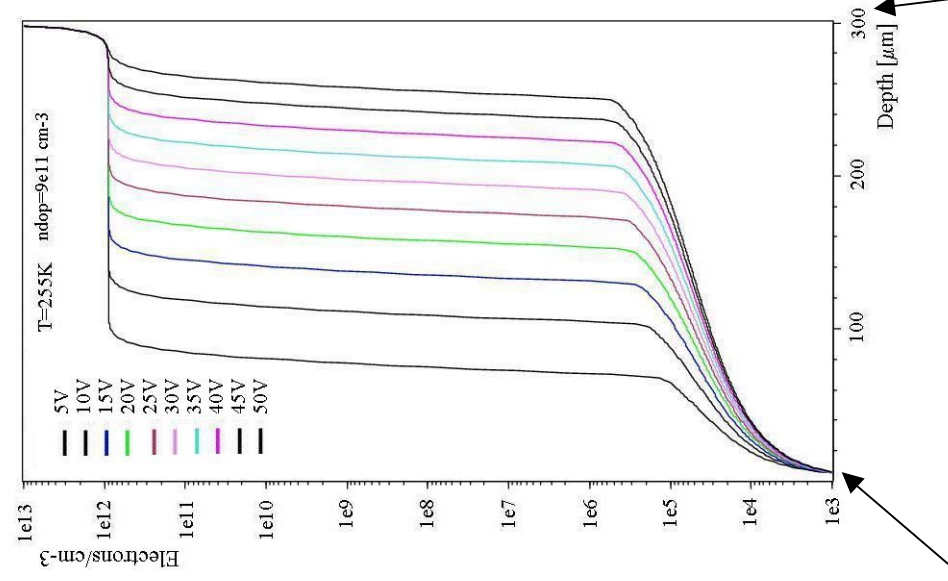
n⁺-implant Note the presence of an electric field in the ‘non-depleted’ bulk at low biases and the ‘double-junction’

ISE simulation of the majority carrier concentration in a silicon diode before and after irradiation ($4 \times 10^{14} \text{ p cm}^{-2}$)



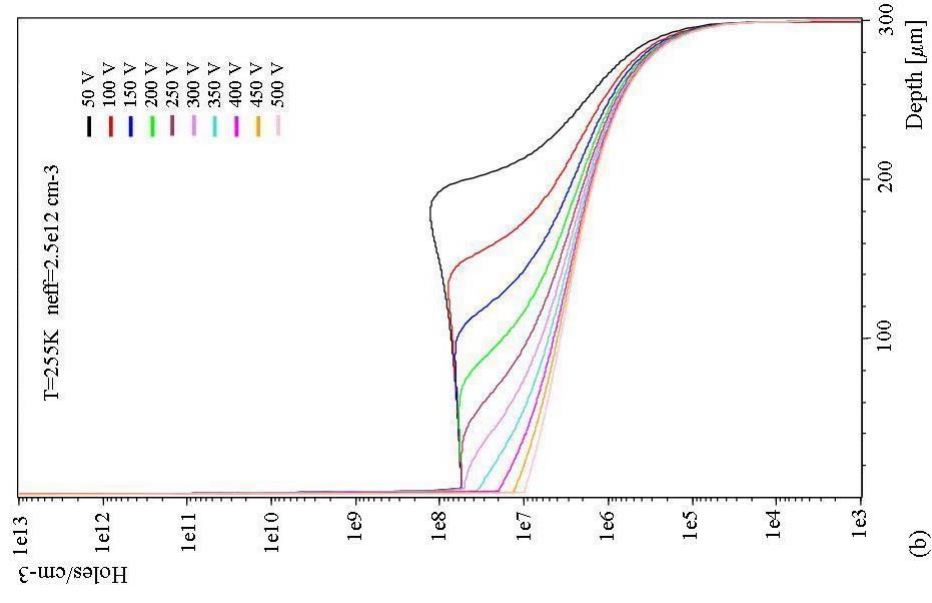
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p⁺-implant

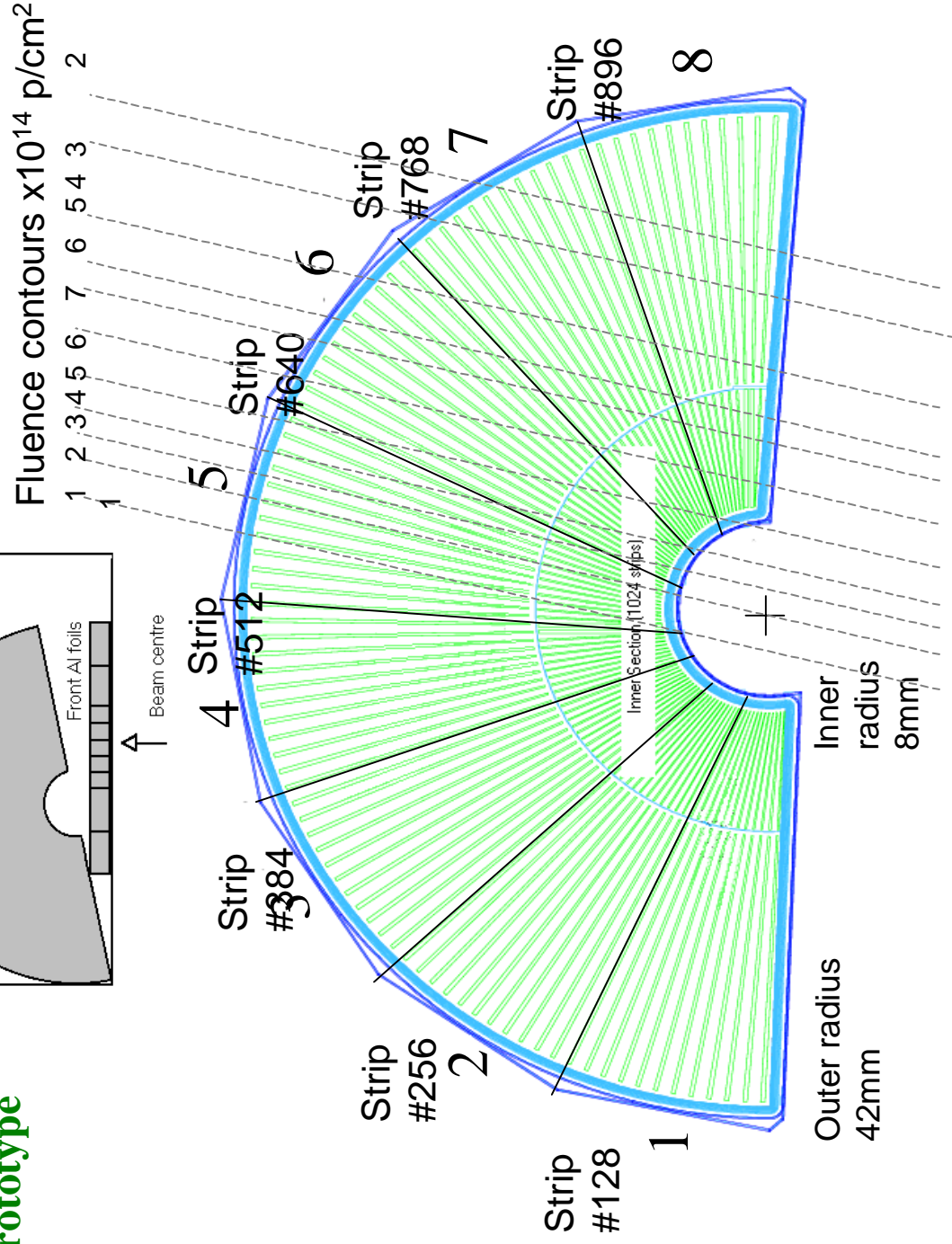
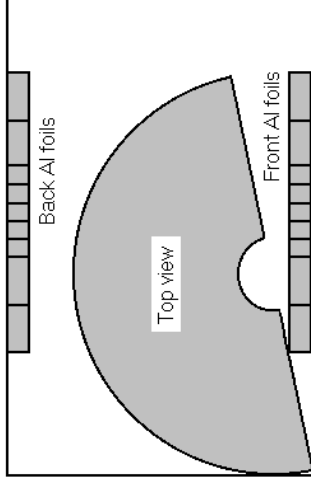
n⁺-implant



(b)

VERTEX 2002 – Hawaii, 3-7 Nov. 2002

Non-homogenous irradiation of large area LHCb VELO phi-type prototype detectors

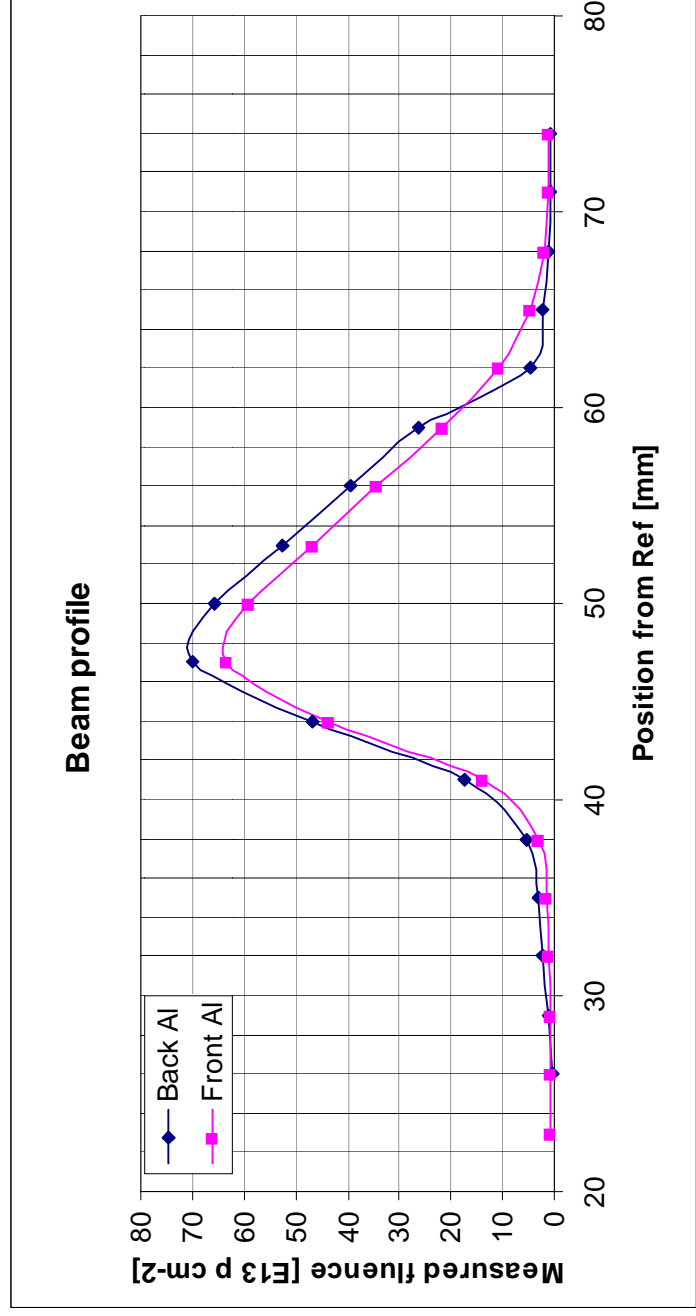




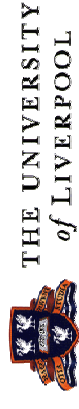
Irradiated devices :

200 μm n-in-n } Irradiated together, maximum
200 μm p-in-n } fluence $\sim 7 \cdot 10^{14}$ p cm^{-2}

300 μm p-in-n } Maximum fluence $\sim 4.6 \cdot 10^{14}$ p
 cm^{-2}

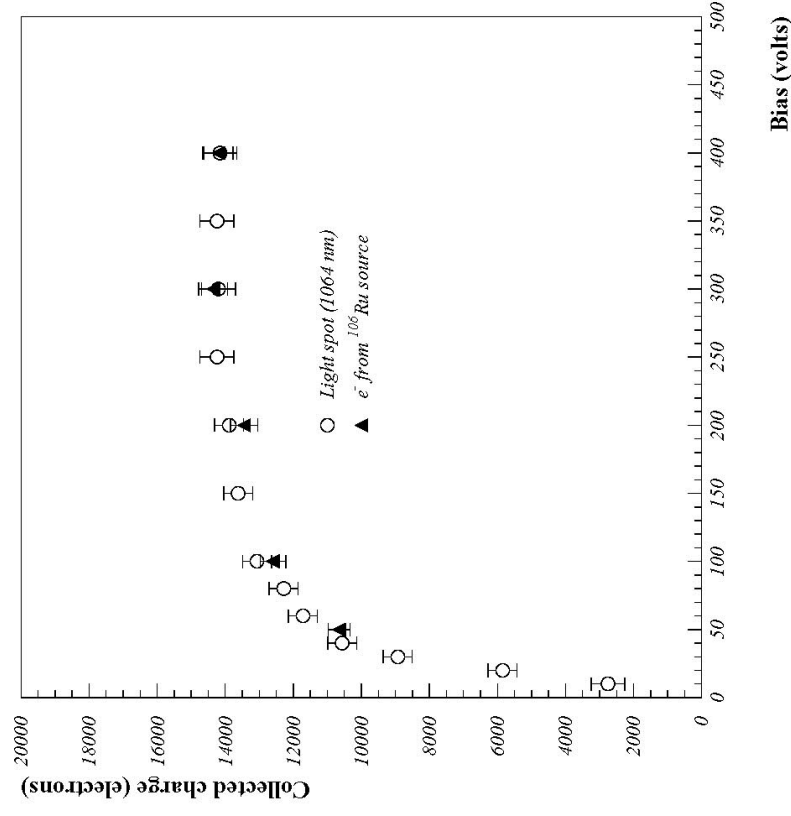


Tools for studying the non-homogeneously irradiated detector: comparison between CCE with infrared (1060 nm) laser and ^{106}Ru β -source. All measurements with SCT128-VG (LHC speed electronics)



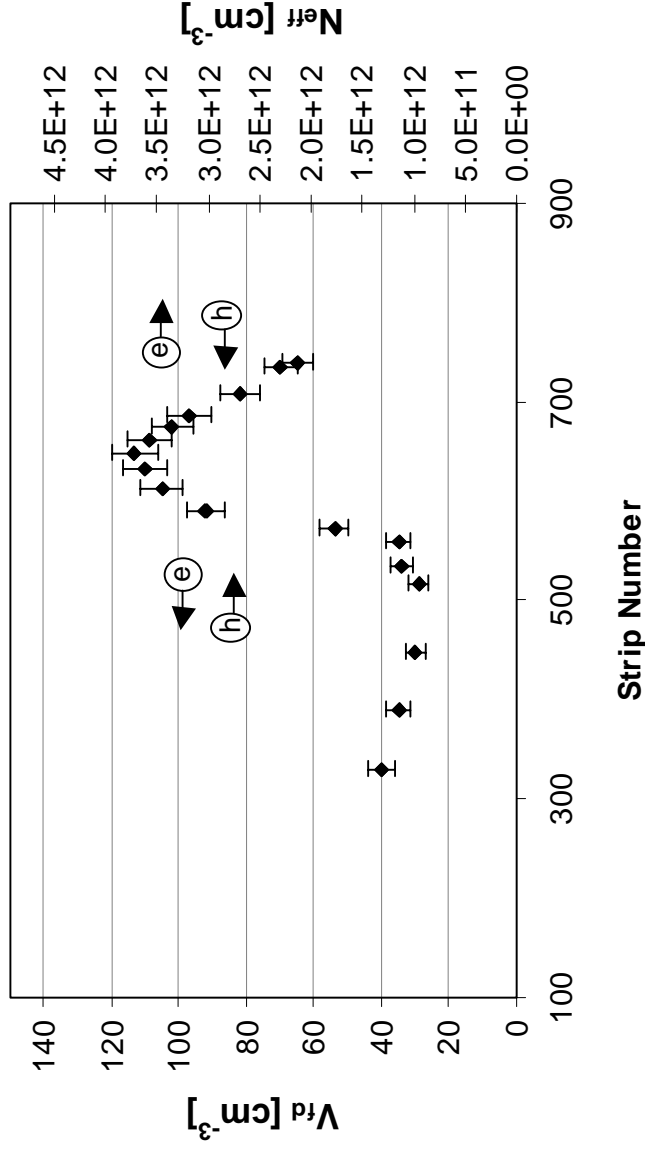
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CCE(V) for irradiated, 200 μm thick, detector with laser data (normalised to value at 400V) superimposed



From fits to the CCE(V), the depletion voltages for the different regions of the detector can be extracted.

The V_{fd} (N_{eff}) profile corresponds to the irradiation profile and allows to study the properties of the detector with a steep gradient of $V_{fd}(N_{eff})$.



Gradient of N_{eff} can introduce a 'transverse' component of the electric field and a distortion in the reconstructed cluster position. Distortions are expected to have opposite sign of the opposite sign of the gradient of N_{eff} .

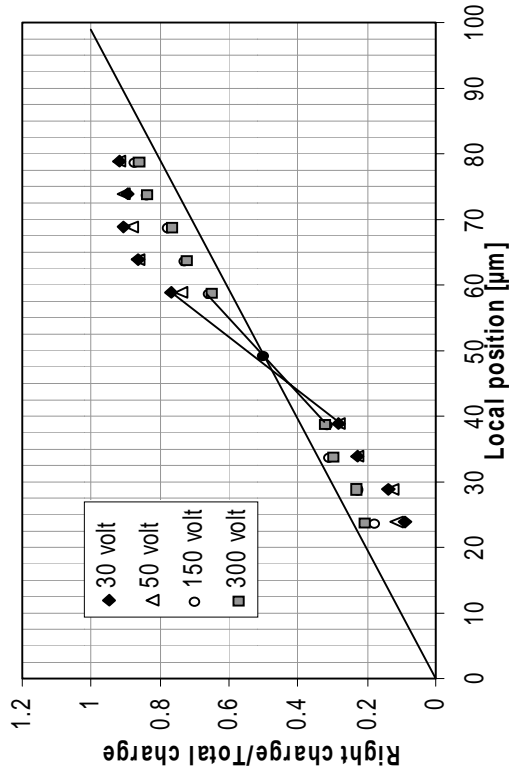
N-in-n 200 μm detector



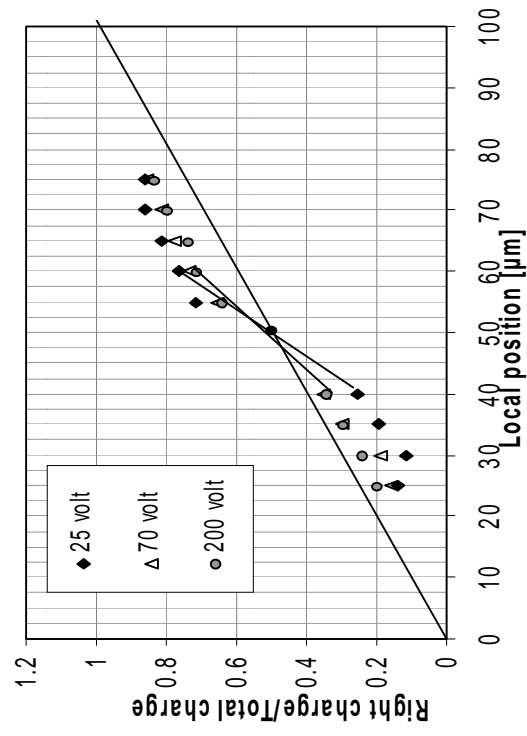
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$$\eta = Q_R / (Q_R + Q_L)$$

Strip 517-518
Vfd=29 V



Strip 534-535
Vfd=34 V



N-in-n 200 μm detector

$$\eta = Q_R / (Q_R + Q_L)$$

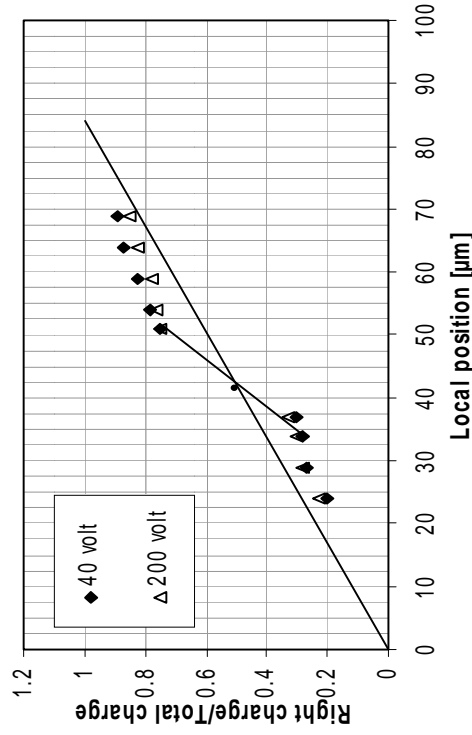


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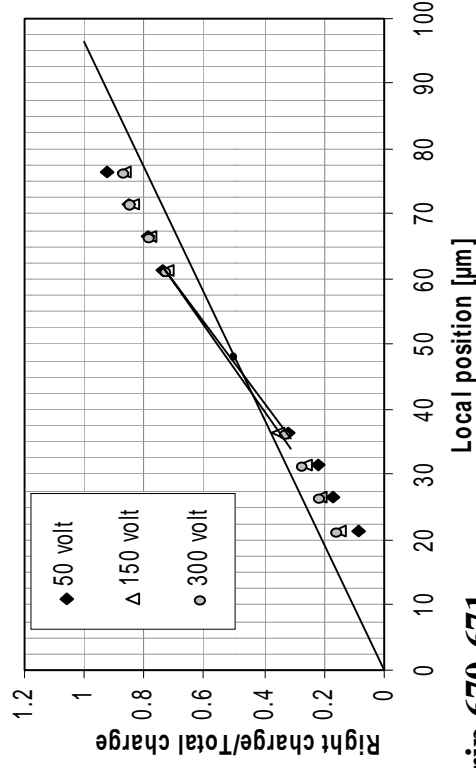
Strip 582-583

Vfd=90V



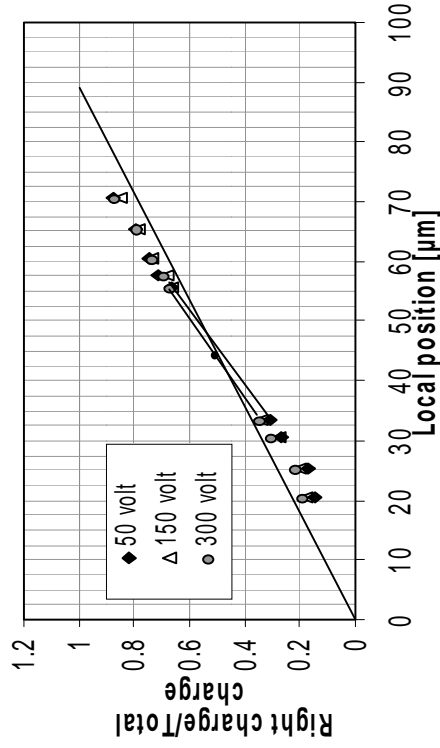
Strip 612-613

Vfd=105V



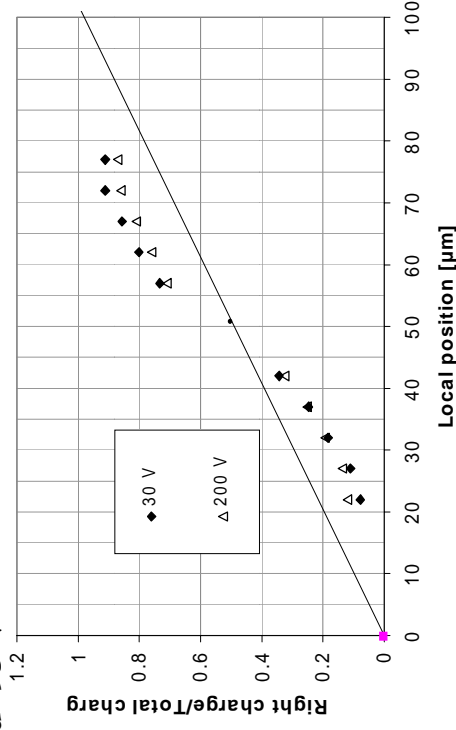
Strp 632-633

Vfd=110V



Strip 670-671

Vfd=95 V

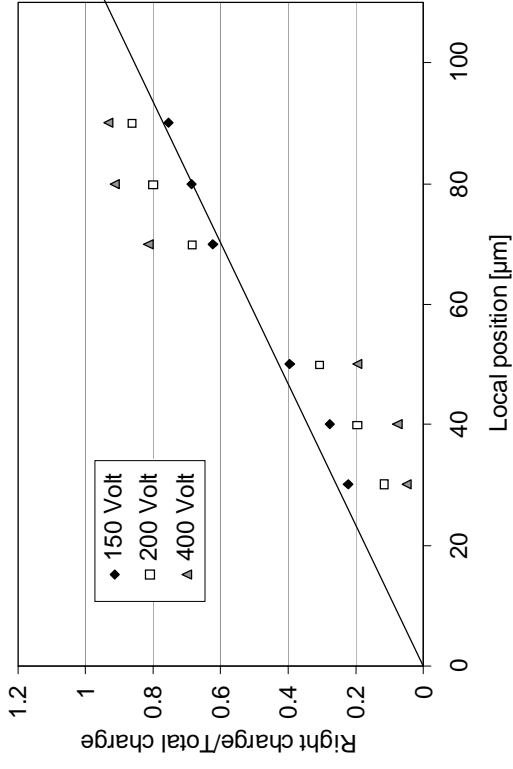
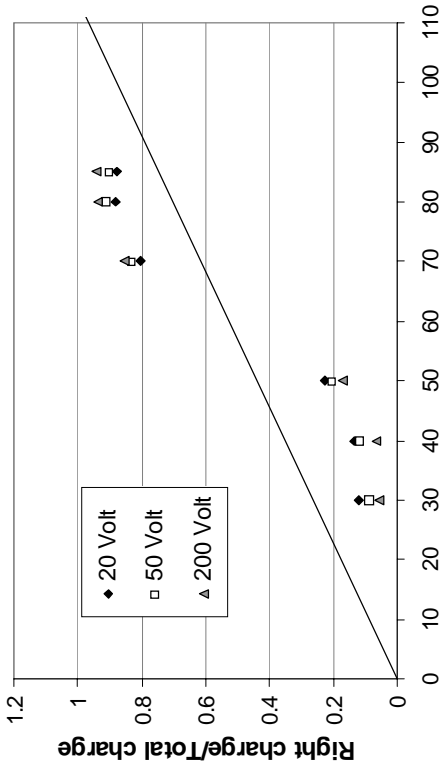


P-in-n 300 μm detector $\eta = Q_R / (Q_R + Q_L)$

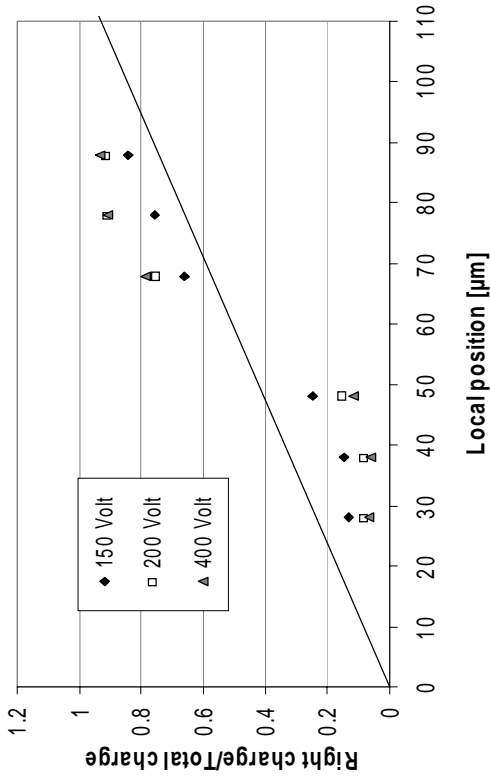


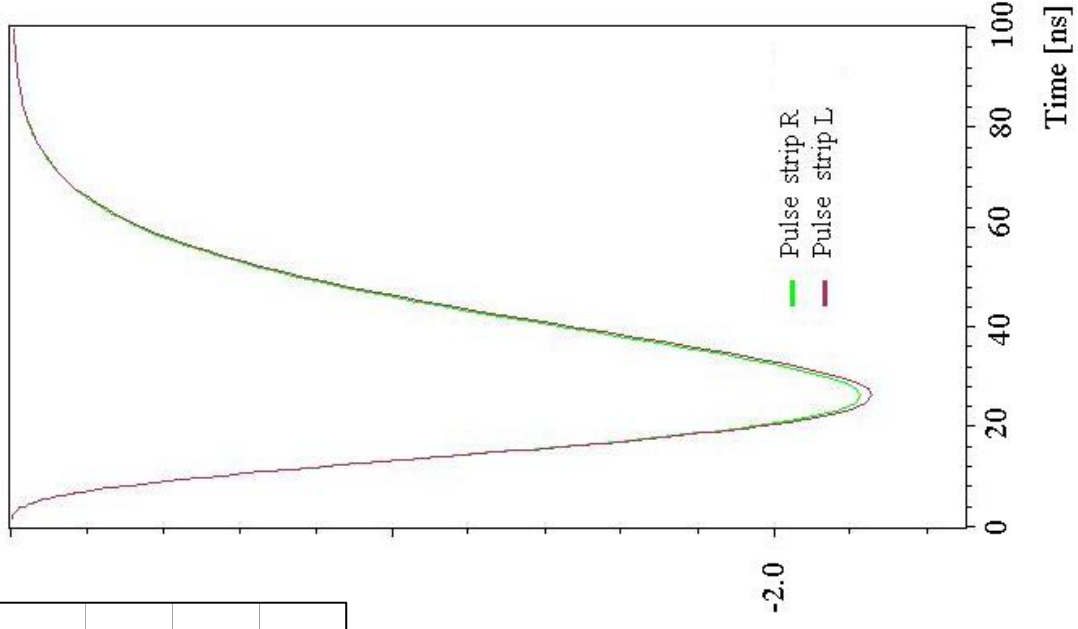
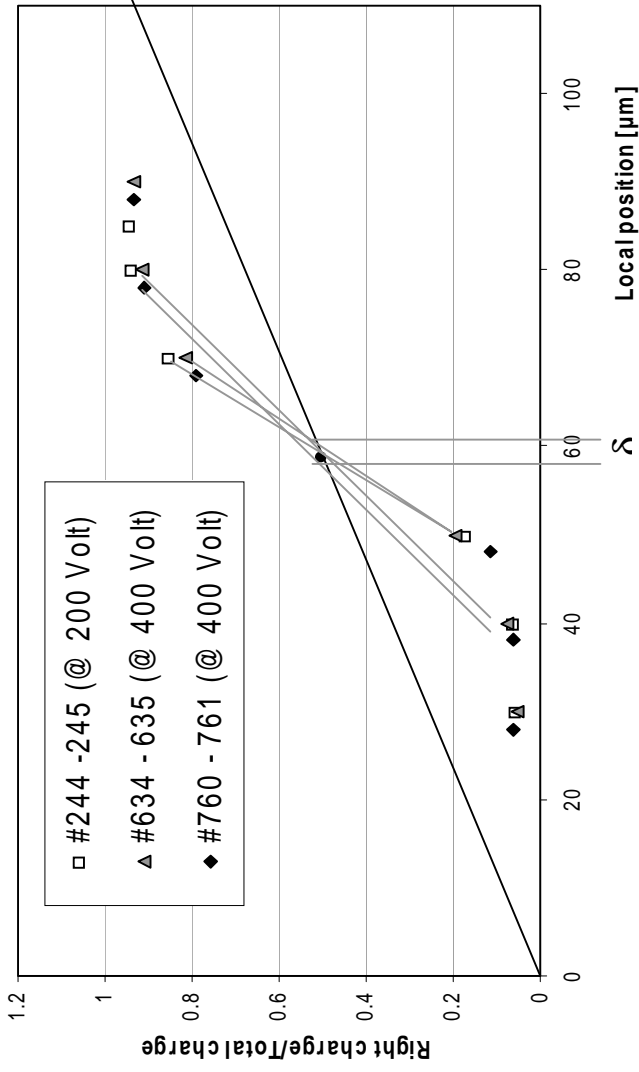
Irradiated region with positive gradient of $|N_{\text{eff}}|$ as a function of the strip number (Vfd 230 V)

Low radiation region Vfd=75V

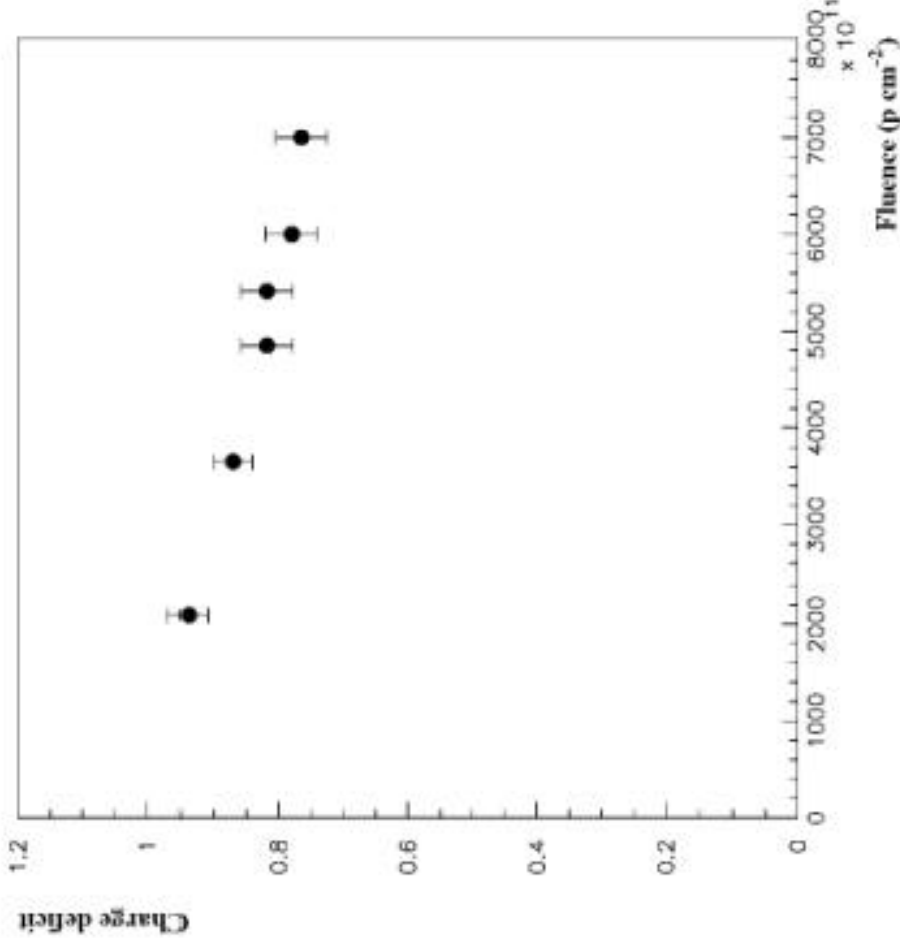


Irradiated region with negative gradient of $|N_{\text{eff}}|$ as a function of the strip number (Vfd 230 V)





No evidence of distortion (spread observed (δ) is approximately $\pm 2\mu\text{m}$) in the reconstructed cluster position due to the high gradient of Neff in the detector. The experimental results are also supported by ISE simulations

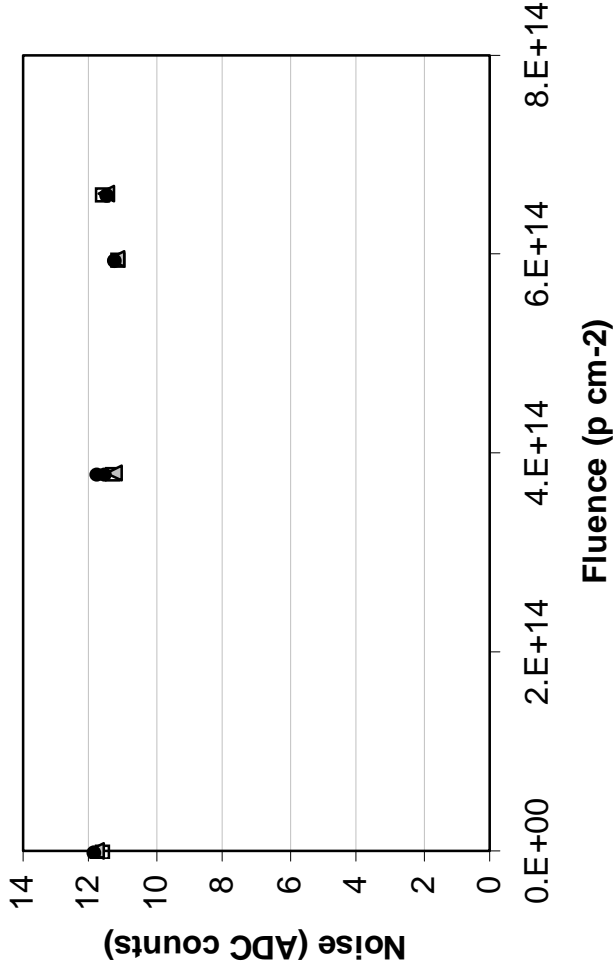


Signal (^{106}Ru β -source) degradation as a function of fluence in the non-homogeneous irradiated detector (n-in-n).

Noise as a function of the applied bias: dose varying from $2 \cdot 10^{14}$ to $7 \cdot 10^{14} \text{ p cm}^{-2}$



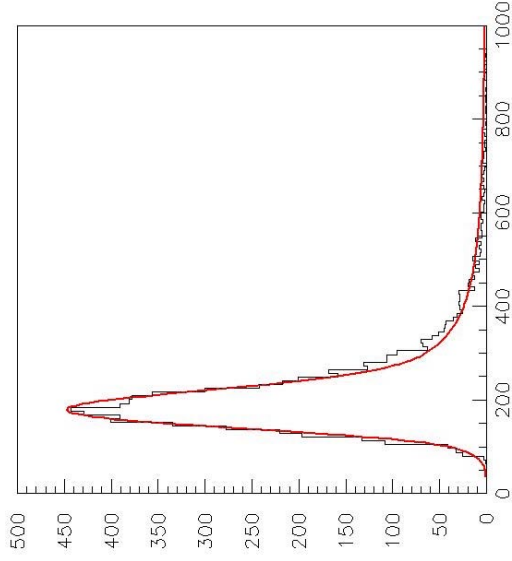
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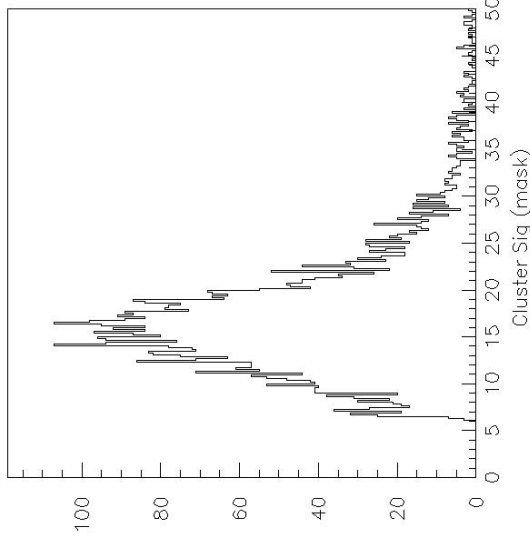
The noise doesn't change with irradiation and bias (when the total reverse current is kept low, below 1mA)



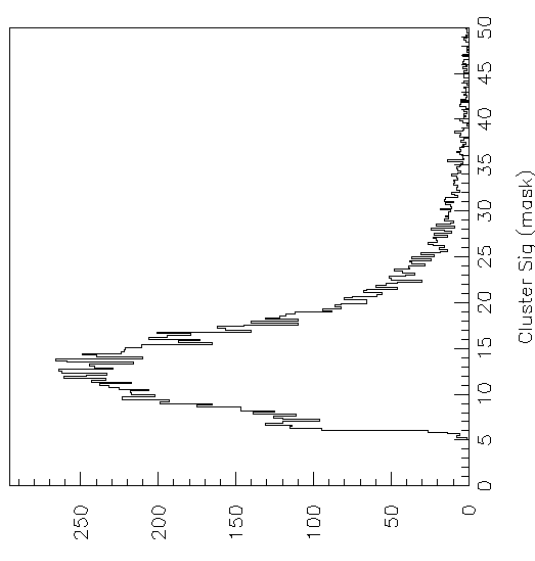
The signal/noise measured with this 200 μm thick detector with about 7.5 pF input capacitance is about 16 and 12.5 in the non-irradiated and in the most irradiated areas respectively, as measured with the SCT128-VG analogue electronics



Signal of fast electrons from ^{106}Ru source (non-irr. area)

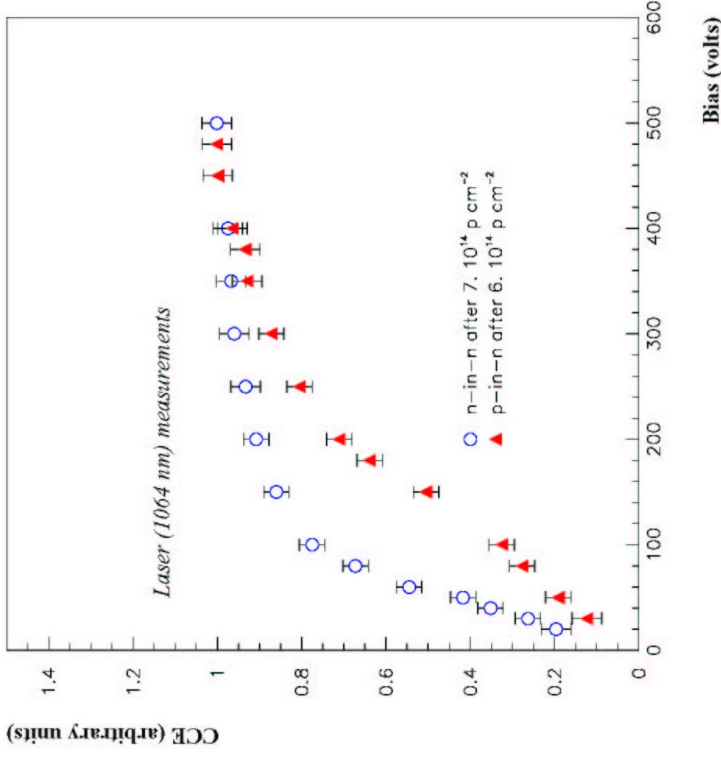


Cluster significance (non-irr. area)



Cluster significance (irr. area)

- For simple one dimensional structures eg large area diodes little difference is expected between the signals seen on the n-side or the p-side.
- Direct comparisons of n-side and p-side detectors with the same masks fabricated on the same material confirm the superiority of n-side read-out after irradiation.



Laser (1060 nm) CCE(V) in the highest irradiated areas for a n-in-n ($7 \cdot 10^{14}$ p cm⁻²) and p-in-n ($6 \cdot 10^{14}$ p cm⁻²) 200 μ m thick microstrip detectors

Conclusions:

- ISE simulations describe well the device properties also after irradiation and successfully predict charge collection properties and are being used for updating designs.
- The effect of non-uniform irradiations (with resulting high gradient - $2.6 \cdot 10^{12} \text{ cm}^{-4}$ - of N_{eff} across the detector and perpendicular to the strip) has been studied and small limit to the distortion of the reconstructed cluster position have been placed.
- The charge collected at a given voltage is reduced both by the **trapping** and by the **changes to the effective doping concentration**.
- The **former** is addressed by n-side read-out while the **latter** can be helped by using an oxygen enhanced substrate.
- Combining the techniques of n-side read-out (to reduce the influence of trapping) and enhanced interstitial oxygen should yield tracking detectors good to 10^{15} p/cm^2 at least.